



PATENT
Customer No. 22,852
Attorney Docket No. 8071.0007

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Takeshi MITSUISHI et al.

Application No.: 09/986,907

Filed: November 13, 2001

For: COMPOSITION FOR VAPOR
DEPOSITION, METHOD FOR
FORMING AN ANTIREFLECTION
FILM, AND OPTICAL ELEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

TECHNOLOGY CENTER 2800

JAN - 7 2004

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REPLY

This reply is filed in response to the Office Action dated August 26, 2003. A request for a one-month extension of time and appropriate fee is being filed with this reply. Favorable reconsideration of this application is requested in view of the remarks below.

REMARKS

Claims 1-17 remain pending in this application. The indication that claims 6-8, 9-17/6 and 9-17/8 (as they depend from claims 6 or 8) are directed to patentable subject matter and would be allowable if placed in independent form is gratefully acknowledged.

Claim 17 has been objected to because claim 17 is allegedly a Markush claim and allegedly must have the phrase "a group consisting of" following the term "from" in

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